










<b>FORM PTO-1449</b> <b>INFORMATION DISCLOSURE STATEMENT</b>				Atty Docket <b>OKI 361</b>		Application No. <i>10/635,506</i> <b>To Be Assigned</b>	
				Applicant <b>Toshikazu MIZUKOSHI</b>			
				Filing Date <b>August 7, 2003</b>		Group Unit <i>2813</i> <b>To Be Assigned</b>	
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	6,268,629	07/31/01	Noguchi			
	AB	6,245,684	06/12/01	Zhao et al.			
	AC	6,051,479	04/18/00	Hong			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AK	2001-244327	09/07/01	Japan			Abstract
	AL	2000-101071	04/07/00	Japan			Abstract
	AM	11-102961	04/13/99	Japan			Abstract
	AN	10-223747	08/21/98	Japan			Abstract
<b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AO	1991.3, Semiconductor World, p128-p131, and translation thereof.					
	AP						
	AQ						
	AR						
Examiner 				Date Considered <i>4/27/04</i>			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							